Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/840,222	IWAMI ET AL.
Examiner	Art Unit

EDMUND H. LEE

1732

SEARCHED				
Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
264	248,250	12/29/2006	EHL	
	279.1,325			
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SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
UPDATED EAST	12/29/2006	EHL
UPDATED CLASS/SUBCLASS SEARCH264/248,250,279.1,325		
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